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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/706,382	11/12/2003	Wen-Jui Fu	TS99-431/909	6374
47390 7	7590 09/20/2005		EXAM	INER
THOMAS, KAYDEN, HOSTEMEYER & RISLEY LLP			SCHILLINGER, LAURA M	
100 GALLERIA PARKWAY SUITE 1750		ART UNIT	PAPER NUMBER	
ATLANTA. C	GA 30339		2813	

DATE MAILED: 09/20/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
· · · · · · · ·	10/706,382	FU ET AL.
Office Action Summary	Examiner	Art Unit
	Laura M. Schillinger	2813
The MAILING DATE of this communication ap Period for Reply	ppears on the cover sheet with the	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING I - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailine earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION .136(a). In no event, however, may a reply be divill apply and will expire SIX (6) MONTHS from the course the application to become ABANDO	ON. timely filed om the mailing date of this communication. NED (35 U.S.C. § 133).
Status		
1)	is action is non-final. ance except for formal matters, p	
Disposition of Claims		
4) ☐ Claim(s) 1-20 is/are pending in the applicatio 4a) Of the above claim(s) 9-20 is/are withdray 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-8 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/ Application Papers 9) ☐ The specification is objected to by the Examin 10) ☐ The drawing(s) filed on is/are: a) ☐ acceptable and applicant may not request that any objection to the Replacement drawing sheet(s) including the corresistance. 11) ☐ The oath or declaration is objected to by the Examination of the corresistance.	wn from consideration. for election requirement. her. ccepted or b) □ objected to by the edrawing(s) be held in abeyance. Section is required if the drawing(s) is estimated.	See 37 CFR 1.85(a). objected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document accepted accepted copies of the priority document accepted application from the International Bure * See the attached detailed Office action for a list	nts have been received. nts have been received in Applic iority documents have been rece au (PCT Rule 17.2(a)).	ation No ived in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0 Paper No(s)/Mail Date 1/29/04.	4) Interview Summa Paper No(s)/Mail 8) 5) Notice of Informa 6) Other:	

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DETAILED ACTION

Election/Restrictions

Applicant's election of claims 1-8 in the reply filed on 7/19/05 is acknowledged.

Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Jones (401) as applied to claim 1 above, and further in view of Araki et al ('098).

Jones teaches the following claimed limitations as cited below; citations to the Araki reference are separately identified:

1. A method of reducing fluorine contamination on a integrated circuit wafer surface comprising: placing an integrated circuit wafer on a cathode stage wherein said integrated circuit wafer comprises a surface contaminated with fluorine (Col.3, lines: 10-30); and bombarding said integrated circuit wafer surface with a plasma to remove said fluorine from said surface to thereby increase the rate of said fluorine removal (Col.1-2, lines: 50-10).

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However, Jones fails to teach Applicant's additional claimed limitation wherein said cathode stage is heated to a high temperature.

Araki et al ('098) teaches a similar process including a hot cathode (Araki-Col.15, lines: 40-60).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Jones to further include the hot cathode taught by Araki because as Araki teaches, since the cathode can be heated like a resistor, and since hot electrons can be generated from the cathode, the rise in charge can be done rapidly and simply (Araki- Col.15, lines: 45-55)

- 2. The method according to Claim 1 wherein said surface comprises bonding pads (Abs., lines: 1-5).
- 3. The method according to Claim 1 wherein said surface comprises an aluminum containing layer (Col.3, lines: 13-20).
- 4. The method of claim 1, wherein said heating of said cathode stage comprises a temperature range between 50 and 500 degrees C (Araki Col.15, lines: 40-60).
- 5. The method according to Claim 1 wherein said step of bombarding comprises N_2 gas (Col.1, lines: 60-65).

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6. The method according to Claim 1 wherein said step of bombarding comprises argon gas (Col.1, lines: 60-65).

- 7. The method according to Claim 1 wherein said step of bombarding further comprises a reducing gas to form HF from said fluorine contamination wherein said HF is removed by said bombardment gas (Col.3, lines: 50-55).
- 8. The method according to Claim 7 wherein said reducing gas comprises H₂ (Col.3, lines: 50-55).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Laura M. Schillinger whose telephone number is (571) 272-1697. The examiner can normally be reached on M-T, R-F 7:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl W. Whitehead, Jr. can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

09/16/05

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